

UTILITY PATENT APPLICATION
TRANSMITTAL UNDER 37 CFR 1.53(b)

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CHEMICAL MECHANICAL PLANARIZATION
OF WAFERS USING FIXED POLISHING PADS
AND A NANOPARTICLE COMPOSITION

First Named Inventor (or Application Identifier):

Venkata R. Gorantla, et al

ATTORNEY DOCKET 85168PCW
Customer No. 01333

Express Mail Label No.

EV293511115US

Date: September 12, 2003

19704 U.S. PTO
10/10/662215

09/12/03

Enclosed are:

1. Specification

2. 3 Sheet(s) of drawing(s)

3. Information Disclosure Statement Under 37 CFR 1.97.

4. Combined Declaration for Patent Application and Power of Attorney:

4a. New

4b. Copy from a prior application (37 CFR 1.63(d) (for continuation/divisional with Box 11 completed)

5. Incorporation by Reference (useable if Box 4b is checked) The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied under Box 4b, is considered as being part of the disclosure of the accompanying application and is hereby incorporated by reference therein.

6. Assignment of the invention to

7. Certified copy of a priority

8. Associate Power of Attorney

9. Deletion of Inventor(s).
Signed statement attached deleting inventor(s) named in the prior application, see 37 CFR 1.63(d)(2) and 1.33(b).

10. If a 111A application prior to examination of the above-identified application, amend the specification at Page 1, after the title, by inserting the following:

--CROSS REFERENCE TO RELATED APPLICATION

Reference is made to and priority claimed from U.S. Provisional Application Serial No. 60/409,992, filed 09-12-2002, entitled PROCESS FOR CHEMICAL MECHANICAL POLISHING OF BLANKET FILM AND PATTERNED WAFERS USING FIXED ABRASIVE PADS.

If a CONTINUING APPLICATION, check appropriate box and supply the requisite information:

11. Continuation Divisional Continuation-in-part (CIP) of prior application No.:

12. Please address all written communications to Thomas H. Close, Patent Legal Staff, Eastman Kodak Company, 343 State Street, Rochester, NY 14650-2201.
Please Direct all telephone calls to Peyton C. Watkins at 585-477-8282.

The filing fee has been calculated as shown below:

FOR:	NO. FILED	NO. EXTRA	RATE	FEE
BASIC FEE				\$ 750
TOTAL CLAIMS	33 - 20 =	13	x 18 =	\$ 234
INDEPENDENT CLAIMS	3 - 3 =	0	x 84 =	\$ 0
MULTIPLE DEPENDENT CLAIM PRESENTED			+ 280	\$ 0
			TOTAL	\$ 984

Please charge my Eastman Kodak Company Deposit Account No. 05-0225 in the amount of \$ 984
A duplicate copy of this sheet is enclosed

The Commissioner is hereby authorized to charge any additional filing fees required under
37 CFR 1.16 or credit any overpayment to Eastman Kodak Company Deposit Account No. 05-0225.
A duplicate copy of this sheet is enclosed.

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Telephone: 585-477-8282
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Attorney for Applicants
Registration No. 36,390

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Venkata R. K. Gorantla, et al

CHEMICAL MECHANICAL
PLANARIZATION OF WAFERS OR
FILMS USING FIXED POLISHING
PADS AND A NANOPARTILCE
COMPOSITION

Serial No. *To Be Assigned*

Filed *Herewith*

Group Art Unit: *To Be Assigned*

Examiner: *To Be Assigned*

Express Mail Label No.

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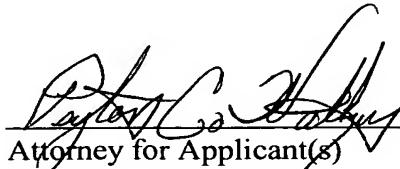
Sir:

LETTER UNDER RULE 53

Pursuant to Rule 53, the above-identified application, enclosed herewith (including specification and claims), is being filed without a signed declaration or assignment in the names of the inventor(s), Venkata R. K. Gorantla, Suryadevara V. Babu. The declaration and assignment will be filed later.

Please address all correspondence to Patent Legal Staff, Eastman Kodak Company, Rochester, New York 14650-2201. Please direct all telephone communications to Peyton C. Watkins at 585-477-8282.

Respectfully submitted,



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